

Docket No.: 50103-537

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Nobuo KURATAKA, et al. :
Serial No.: : Group Art Unit:
Filed: June 25, 2003 : Examiner:
For: METHOD FOR PROTECTING SURFACE OF STAMPER/IMPRINTER DURING
MANUFACTURE THEREOF

CLAIM OF PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

United States Provisional Patent Application No. 60/393,573, filed July 1, 2002

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Aaron Weisstuch, Ph.D.
Registration No. 41,557

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 AW:mlw
Facsimile: (202) 756-8087
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